



I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Mail Stop Amendment
Commissioner for Patent
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED TO CHARGE
ANY DEFICIENCY IN FEES FOR THIS PAPER TO
DEPOSIT ACCOUNT NO. 23-0975

on 5/1/06

Michael S. Huppert

name of person signing certification

Michael S. Huppert

Signature

May 1, 2006

Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 5686**
Mitsuo SAITOH et al. : Attorney Docket No. 2003_1228A
Serial No. 10/649,670 : Group Art Unit 1763
Filed August 28, 2003 : Examiner Allan W. Olsen

PLASMA PROCESSING METHOD AND APPARATUS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of November 29, 2005, the period for response having been extended for two (2) months by the attached petition, please amend the present application as follows:

Amendments to the Abstract

Kindly replace the original abstract with the attached substitute abstract.